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EF279050369US



PTO/SB/08

Submitted: October 15, 2001

Substitute for form 1449/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT				<i>Complete if Known</i>	
				Application Number	09/557,990
				Filing Date	4/25/00
				First Named Inventor	Carducci et al.
				Group Art Unit	1763
				Examiner	Goudreau, G.
Sheet	1	of	2	Attorney Docket	AM 3536

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U.S. PATENT DOCUMENTS						
Examiner Initials	Cite No.	U.S. Patent Document		Name of Patentee or Applicant	Date of Publica- tion	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code			
GAG		4,367,114		Steinberg et al. ✓	1/83	
		5,304,279		Coultas et al. ✓	4/94	
		5,346,579		Cook et al. ✓	9/94	
		5,366,585		Robertson et al. ✓	11/94	
		5,401,351		Samukawa ✓	3/95	
		5,415,728		Hasegawa et al. ✓	5/95	
		5,484,485		Chapman ✓	1/96	
		5,534,751		Lenz et al. ✓	7/96	
		5,558,717		Zhao et al. ✓	9/96	
		5,891,350		Shan et al. ✓	4/99	
		6,030,486		Loewenhardt et al. ✓	2/00	
		6,054,013		Collins et al. ✓	4/00	col. 31, line 37 - col. 32, line 26; col. 34, lines 36-55;
		4,817,558		Itoh ✓	4/89	col. 36, line 65 - col. 37, line 13; col. 50, lines 35-35.
		6,074,518		Imafuku et al. ✓	6/00	col. 12, line 9 - col. 13, line 5.
GAG		6,189,484		Yin et al. ✓	2/01	col. 8, lines 56-58.

Examiner Signature	George Goudreau	Date Considered	4-021
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FOREIGN PATENT DOCUMENTS								
Examiner Initials	Cite No.	Foreign Patent Document			Name of Patentee or Applicant	Date of Publication	Pages, Columns, Lines Where Protection Is Sought or Figures Attached	Yes
		Office	Number	Kind Code				
GPG		EP	0 173 583	✓ A1	Anelva Corp.	3/86		
		EP	0 786 794	✓ A2	Loewenhardt et al.	7/97		
		EP	0 838 843	✓ A2	Collins et al.	4/98		
		JP	5-160032	✓	Kokusai Electric	6/93	Fig. 5, Abstract, Paragraphs 9, 10, 11, 14.	Yes
		JP	7-22389	✓	Hitachi	1/95		Yes
GPG		JP	8-264515	✓	Tokyo Electron	10/96	Fig. 1, 2, Paragraphs 8-10.	Yes

OTHER PRIOR ART — NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No.	Author (in capital letters); title of article; title of book, journal, symposium, catalog, etc.; date; pages; volume/issue no.; publisher; city and/or country where published.	Yes
GPG		Hongching SHAN et al., "MxP+: A new dielectric etcher with enabling technology, high productivity, and low cost-of-consumables", J. Vac. Sci. Tech. B 14(2), pp. 716-723 (USA, Mar. 1996).	✓

Examiner Signature	George Goudreau	Date Considered	4-021
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